



Attorney Docket SEL 203

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
)  
NAKAJIMA et al. )  
)  
Serial No.: 09/635,945 )  
)  
Filed: August 10, 2000 )  
)  
For: Semiconductor Device And Method )  
Of Manufacturing The )  
Semiconductor Device )  
)  
Art Unit: 2811 )  
)  
Examiner: S. Hu )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
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February 10, 2004

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep

Shannon Wallace 2/10/04

Signature

Date

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT E (AFTER FINAL)**

In response to the Final Rejection of October 10, 2003, a one month extension of time being submitted herewith, please amend the above-identified application as follows: